

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Martin Hausner
Serial No.: 10/524,525
Filed: August 18, 2005
Confirmation No.: 1134
Group Art Unit: 1792
Title: METHOD FOR SELECTIVELY REMOVING MATERIAL FROM THE SURFACE OF A SUBSTRATE, MASKING MATERIAL FOR A WAFER, AND WAFER WITH MASKING MATERIAL
Our Ref. No.: BEET-09

PETITION FOR ONE (1) MONTH EXTENSION OF TIME

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.136(a), Applicant respectfully petitions for an extension of time of one (1) month from the Notice of Appeal response date of June 30, 2009 for responding to the outstanding Office Action mailed December 30, 2008 in the above-identified patent application. With the extension of time, the period for response now extends up to and includes September 30, 2009. Please see the electronic fee calculation sheet for the \$130.00 one month extension fee.

If any other charges or credits are necessary to complete this communication, please apply them to Deposit Account No. 23-3000.

Respectfully submitted,



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